Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	21422	(semiconductor near3 (measur$5 test$4 detect$4 determin$4 sens$4 identi$6 evaluat$5 estimat$5 transducer gauge cell monitor$4 comput$5 inspect$5 meter calculat$4)).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:22
L2	353	1 and pick$8.clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:17
L3	49	2 and guid$5.clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:23
L4	7	3 and socket.clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:17
L5	296	(package near3 semiconductor near3 (measur$5 test$4 detect$4 determin$4 sens$4 identi$6 evaluat$5 estimat$5 transducer gauge cell monitor$4 comput$5 inspect$5 meter calculat$4)).clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:22
L6	19	5 and guid$5.clm.	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:23
L7	13	6 and align$8	US-PGPUB; USPAT; EPO; JPO	OR	ON	2005/06/13 16:23